Docket No.: 4917
Inv.: Yasuyuki MATSUI et al.

Title: Method of Manufacturing Single-Crystal Blocks for Slicing off Semiconductor Wafers therefrom

1 of 3

FIG. 1

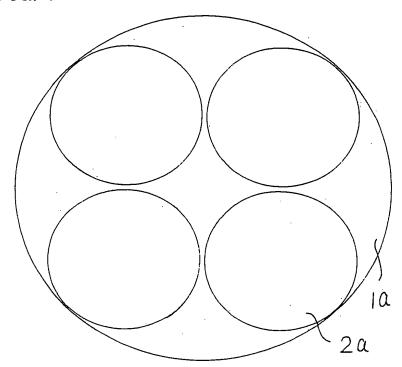
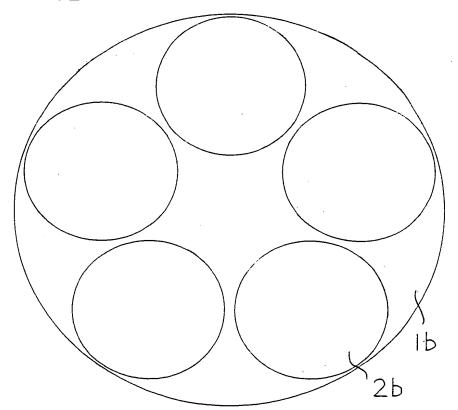


FIG. 2



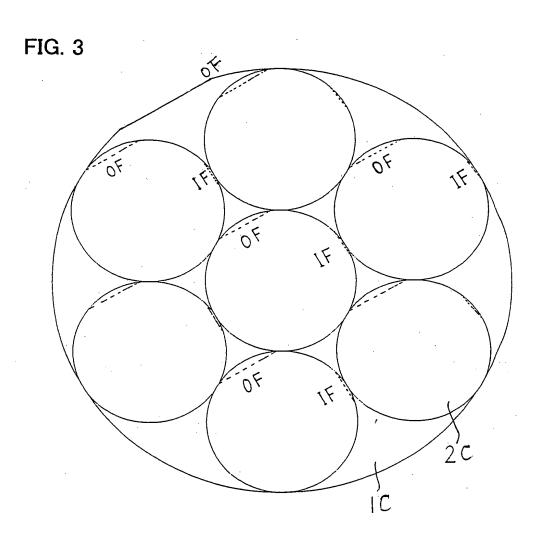


FIG. 4

